PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q77191 Koichi OHTO, et al. Appln. No.: 10/650,193 Group Art Unit: 2826 Examiner: Alexander O. WILLIAMS Confirmation No.: 6245 Filed: August 28, 2003 SEMICONDUCTOR DEVICE HAVING SILICON-DIFFUSED METAL WIRING For: LAYER AND ITS MANUFACTURING METHOD RESPONSE UNDER 37 C.F.R. § 1.111 MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: In response to the Office Action dated February 13, 2006, please consider the remarks provided on the accompanying pages. TABLE OF CONTENTS

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